Spiral 1 / Unit 8

Transistor Implementations

CMOS Logic Gates

Outcomes

- I know the difference between combinational and sequential logic and can name examples of each.
- I understand latency, throughput, and at least 1 technique to improve throughput
- I can identify when I need state vs. a purely combinational function
  - I can convert a simple word problem to a logic function (TT or canonical form) or state diagram
- I can use Karnaugh maps to synthesize combinational functions with several outputs
- I understand how a register with an enable functions & is built
- I can design a working state machine given a state diagram
- I can implement small logic functions with complex CMOS gates

DEMORGAN'S THEOREM

DeMorgan's Theorem

$$F = (\overline{X}+Y) + \overline{Z} \bullet (Y+W)$$

To find F', invert both sides of the equation and then use DeMorgan's theorem to simplify…

$$\overline{F} = \overline{(\overline{X}+Y) + \overline{Z} \bullet (Y+W)}$$

Generalized DeMorgan's Theorem

$$F'(X_1,\ldots,X_n,+,\bullet) = F(X_1',\ldots,X_n',\bullet,+)$$

To find F', swap AND's and OR's and complement each literal. However, you must maintain the original order of operations.

Note: This parentheses doesn't matter (we are just OR'ing X', Y, and the following subexpression)

$$F = (\overline{X}+Y) + \overline{Z} \bullet (Y+W)$$

$$F = \overline{X}+Y + (\overline{Z} \bullet (Y+W))$$

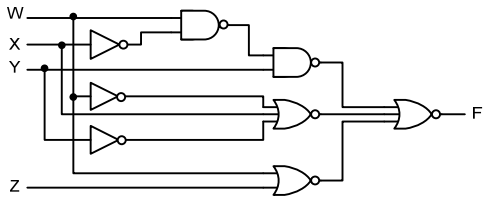
Fully parenthesized to show original order of ops.

$$\overline{F} = X \bullet \overline{Y} \bullet (Z + (\overline{Y} \bullet \overline{W}))$$

AND's & OR's swapped
Each literal is inverted

DeMorgan's Theorem Example

- Cancel as many bubbles as you can using DeMorgan's theorem.

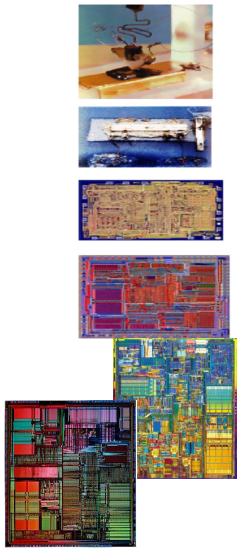


With focus on MOS Transistors

SEMICONDUCTOR TECHNOLOGY

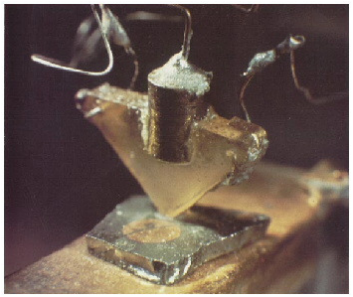
Evolution of transistor in ICs

- BJT invention, Bell Labs, 1947
- Single transistor, TI, 1958
- CMOS gate, Fairchild, 1963
  - First processor, Intel, 1970
- Very Large Scale Integration, 1978
  - Up to 20k transistor
- Ultra Large Scale Integration, 1989
  - More than 1 million per chip
- System-on-Chip, 2002-2015
  - Millions to several billion transistors



Invention of the Transistor

- Vacuum tubes ruled in first half of 20th century
  Large, expensive, power-hungry, unreliable
- 1947: first point contact transistor
  - John Bardeen and Walter Brattain at Bell Labs
  - See *Crystal Fire*
    by Riordan, Hoddeson

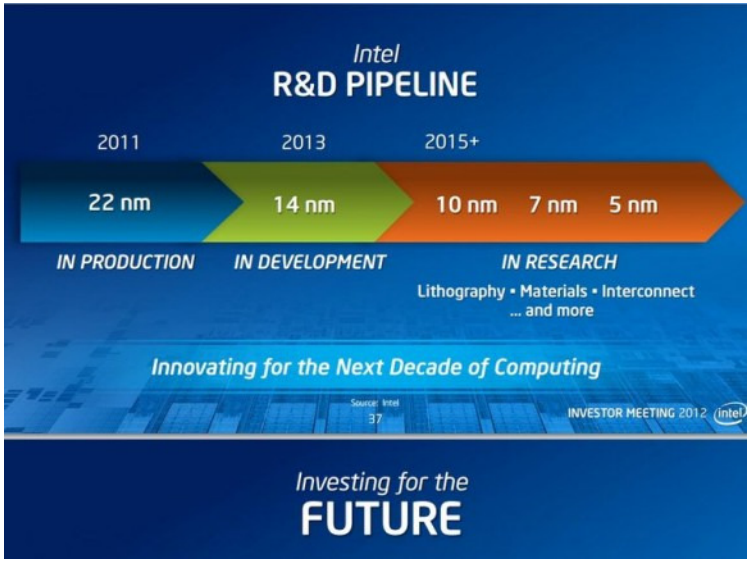


Growth Rate

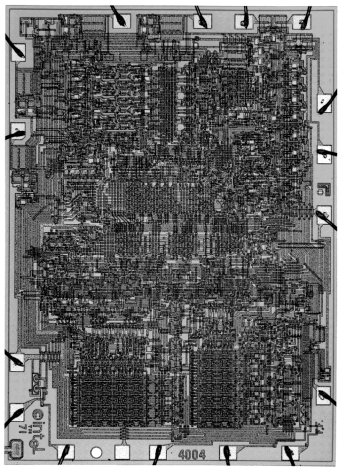
- 53% compound annual growth rate over 50 years
  - No other technology has grown so fast so long
- Driven by miniaturization of transistors
  - Smaller is cheaper, faster, lower in power!
  - Revolutionary effects on society

[Moore65]
Electronics Magazine

Minimum Feature Size



Intel 4004 Micro-Processor



1971
1000 transistors
1 MHz operation

Intel Core I7

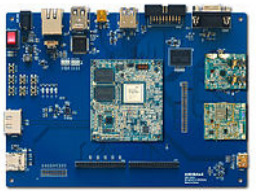
2nd Gen. Intel Core i7 Extreme Processor for desktops launched in Q4 of 2012

- #cores/#threads: 6/12
- Technology node: 32nm
- Clock speed: 3.5 GHz
- Transistor count: Over one billion
- Cache: 15MB
- Addressable memory: 64GB
- Size: 52.5mm by 45.0mm mm^2

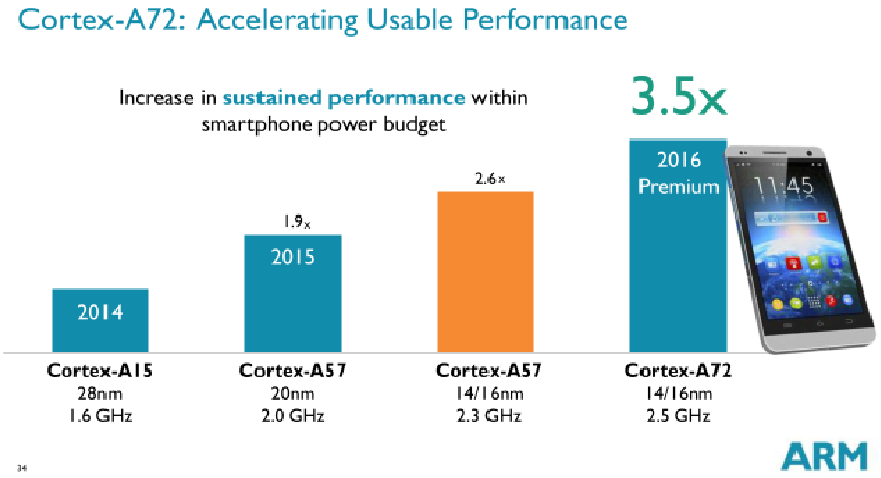
ARM Cortex A15

ARM Cortex A15 in 2011 to 2013

- 4 cores per cluster, two clusters per chip
- Technology node: 22nm
- Clock speed: 2.5 GHz
- Transistor count: Over one billion
- Cache: Up to 4MB per cluster
- Addressable memory: up to 1TB
- Size: 52.5mm by 45.0mm



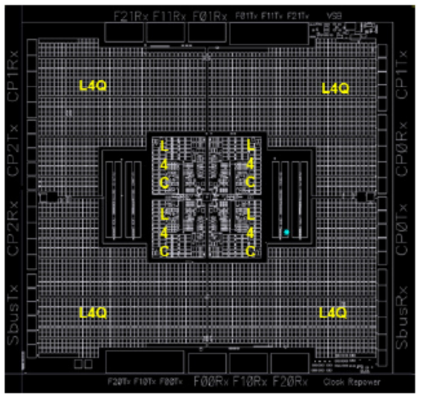
Cortex-A72



IBM z13 Storage Controller

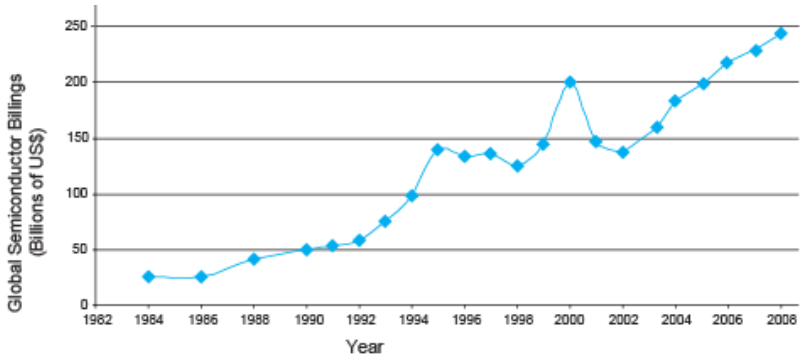
z13 Storage Control (SC) Chip Detail

- **CMOS 14S0 22nm SOI Technology**
  - 15 Layers of metal
  - 7.1 Billion transistors
  - 12.4 Miles of copper wire
- **Chip Area –**
  - 28.4 x 23.9 mm
  - 678 mm^2
  - 11,950 power pins
  - 1,707 Signal Connectors
- **eDRAM Shared L4 Cache**
  - 480 MB per SC chip (Non-inclusive)
  - 224 MB L3 NIC Directory
  - 2 SCs = 960 MB L4 per z13 drawer
- **Interconnects (L4 – L4)**
  - 3 to CPs in node
  - 1 to SC (node – node) in drawer
  - 3 to SC nodes in remote drawers
- **6 Clock domains**

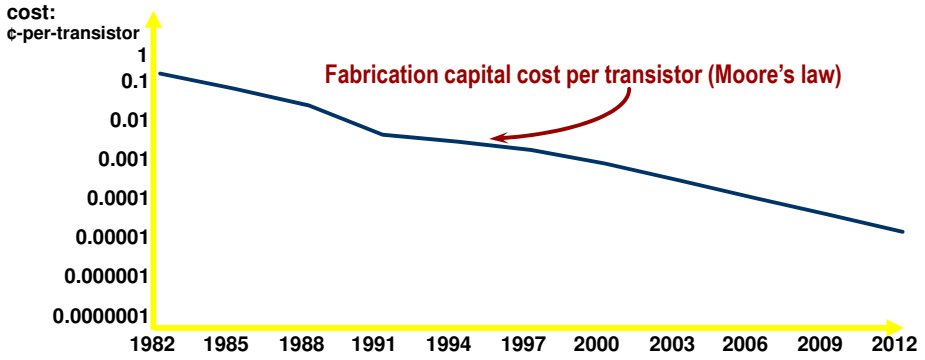


Annual Sales

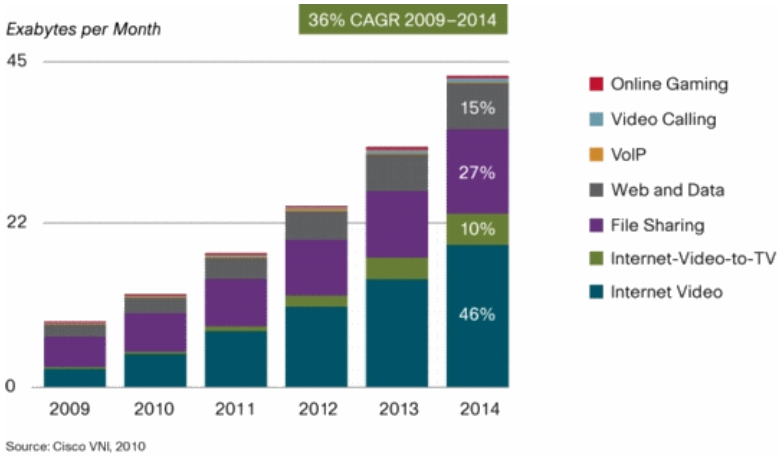
- >10^{19} transistors manufactured in 2008
  - 1 billion for every human on the planet



Cost per Transistor



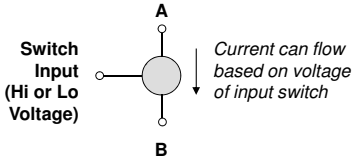
Internet Traffic Growth



TRANSISTOR BASICS

Transistors As Switches

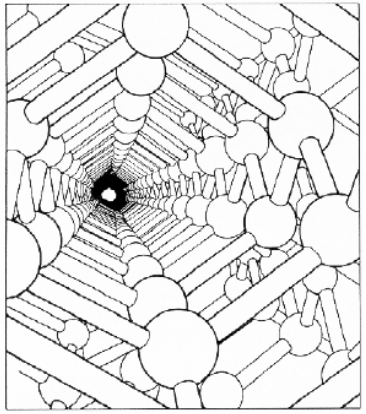
- Transistor act as a form of switch (on / off)
- Different physical structures lead to different kinds of transistors
  - Bipolar Junction Transistor (BJT)
    - Initial technology back in the late 40's – 60's
  - Metal-Oxide-Semiconductor _____ Transistor (MOSFET)
    - Dominates the digital IC market today
- All transistors essentially function similarly with 3 nodes/terminals:
  - 1 node serves as the _____ value allowing current to flow between the other 2 nodes (on) or preventing current flow between the other 2 nodes (off)
  - Example: if the switch input voltage is 5V, then current is allowed to flow between the other nodes



Semiconductors

While there are numerous semiconductor materials available, by far the most popular material is **Silicon**.

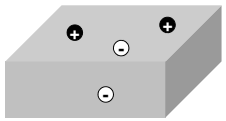
GaAs, InP and SiGe are compound semiconductors that are used in specialized devices.



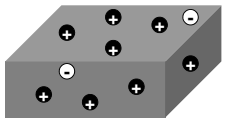
The success of a semiconductor material depends on how easy it is to process and how well it allows reliable high-volume fabrication.

Semiconductor Material

- Semiconductor material is not a great conductor material in its pure form
  - Small amount of free charge
- Can be implanted ("_____") with other elements (e.g. boron or arsenic) to be more conductive
  - Increases the amount of _____ charge

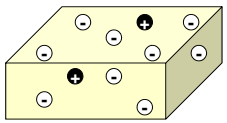


Pure Silicon



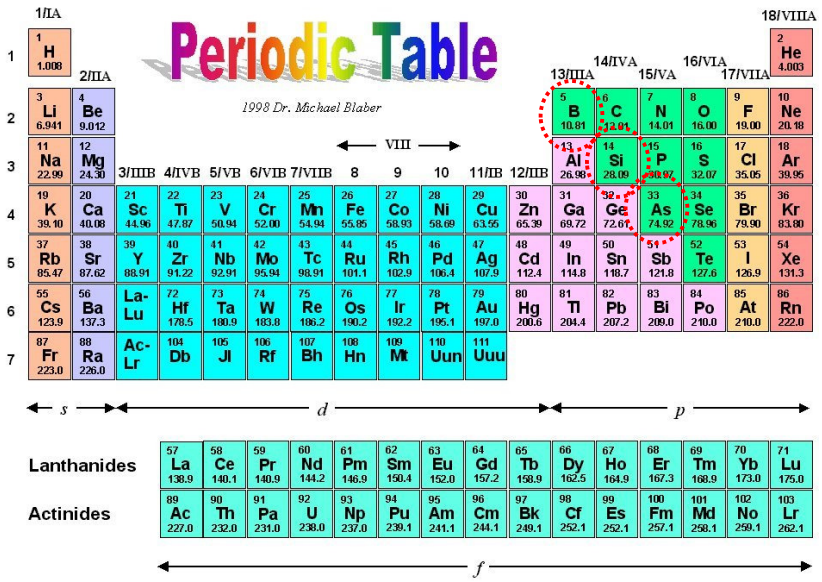
__-Type Silicon
(Doped with boron)

Electron acceptors

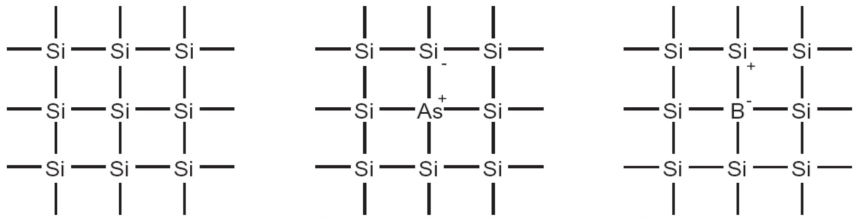


__-Type Silicon
(Doped with arsenic)

Electron donors



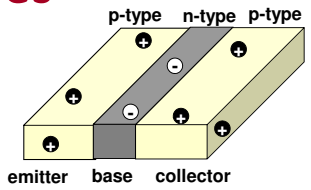
Silicon Lattice and Dopant Atoms



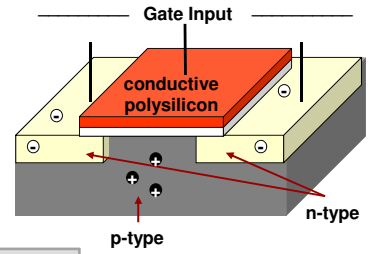
- Pure silicon: 3-D lattice of atoms (a cubic crystal) and a poor conductor
- Conductivity can be raised by adding either donors or acceptor
  - _____: Group V dopant impurities, which have more free electrons than silicon
    - The resulting material is called n-type
  - Group III dopants impurities which have lack of electrons
    - The resulting material is called p-type

Transistor Types

- Bipolar Junction Transistors (BJT)
  - _____ or _____ silicon structure
  - Small _____ into very thin base layer controls large currents between emitter and collector
  - However the fact that it requires a current into the base means it burns power (_____) and thus _____ how many we can integrate on a chip (i.e. density)
- Metal Oxide Semiconductor Field Effect Transistors
  - nMOS and pMOS MOSFETS
  - Voltage applied to insulated gate controls current between source and drain
    - Gate input requires no _____ current…thus low power!



npn BJT

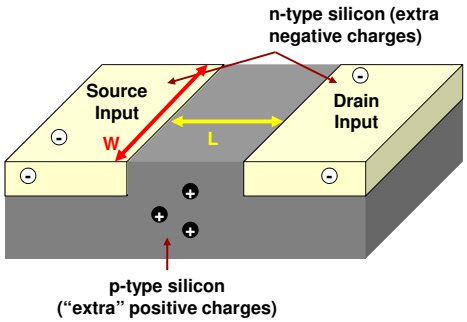


We will focus on MOSFET in this class

N-type MOSFET

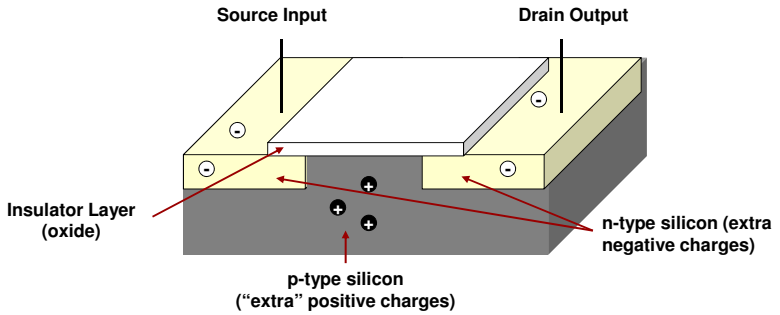
NMOS Transistor Physics

- Transistor is started by implanting two n-type silicon areas, separated by p-type



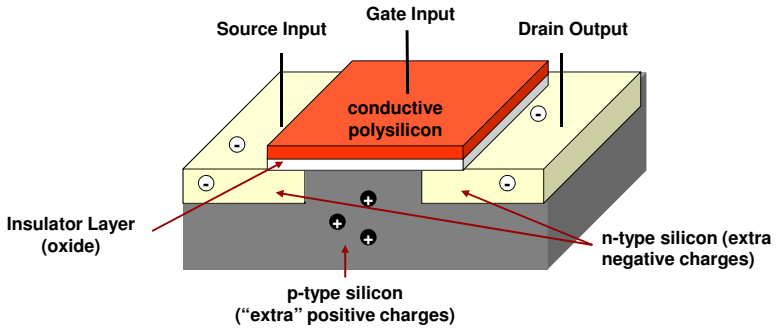
NMOS Transistor Physics

- A thin, insulator layer (silicon dioxide or just "oxide") is placed over the silicon between source and drain



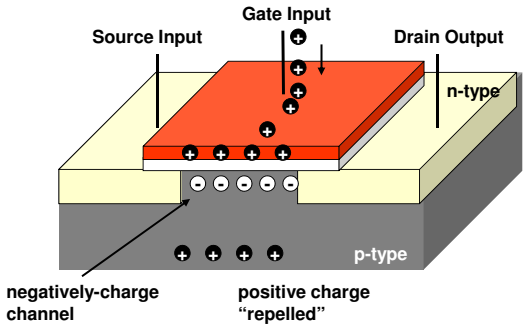
NMOS Transistor Physics

- A thin, insulator layer (silicon dioxide or just "oxide") is placed over the silicon between source and drain
- Conductive polysilicon material is layered over the oxide to form the gate input



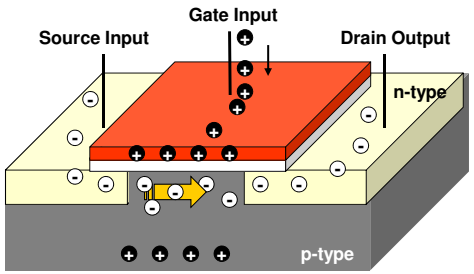
NMOS Transistor Physics

- _____ voltage (charge) at the gate input *repels* the extra positive charges in the p-type silicon
- Result is a negative-charge channel between the source input and drain



NMOS Transistor Physics

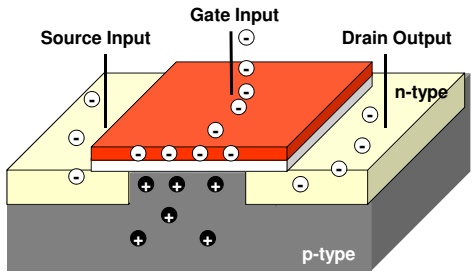
- Electrons can flow through the negative channel from the source input to the drain output
- The transistor is _____



Negative channel between source and drain = Current flow

NMOS Transistor Physics

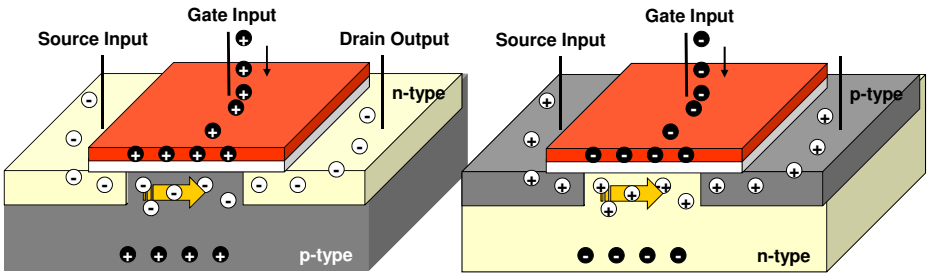
- If a _____ voltage (negative charge) is placed on the gate, no channel will develop and no current will flow
- The transistor is _____



No negative channel between source and drain = No current flow

PMOS vs. NMOS

- PMOS transistors can also be made that are on when the gate voltage is ____ and off when it is _____



Negative channel between source and drain = Current flow

NMOS

"Positive" channel between source and drain = Current flow

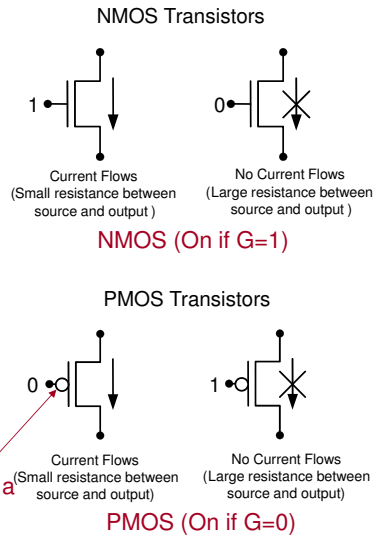
PMOS

Understanding physical constraints

CMOS TRANSISTOR LEVEL IMPLEMENTATION

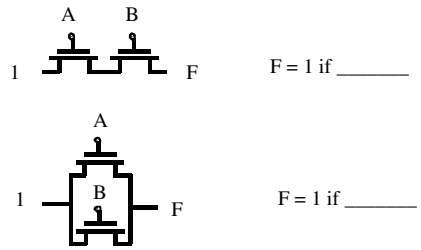
NMOS and PMOS Transistors

- NMOS conducts when gate input is at a high voltage (logic '1')
- PMOS conducts when gate input is at a low voltage (logic '0')



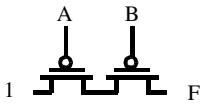
NMOS Transistors in Series/Parallel Connection

- Transistors can be thought as a switch controlled by its gate signal
- NMOS switch closes when switch control input is high

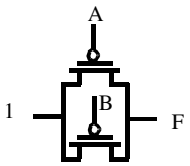


PMOS Transistors in Series/Parallel Connection

- PMOS switch closes when switch control input is low



F = 1 if

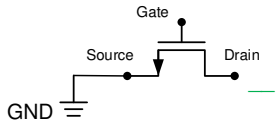


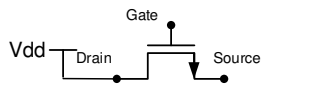
F = 1 if

We All Have Our Strengths

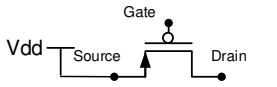
- NMOS are:
  - Good at pulling the output voltage _____
  - Bad at pulling the output voltage _____
- PMOS are:
  - Good at pulling the output voltage _____
  - Bad at pulling the output voltage _____

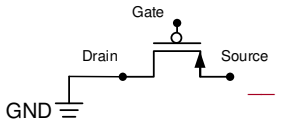
NMOS





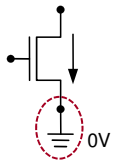
PMOS



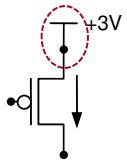


NMOS and PMOS Transistors

- NMOS transistors work best when one terminal is connected to a low voltage source, pulling the other terminal down to that voltage
  - Normally, source terminal is connected to _____
- PMOS transistors work best when one terminal is connected to a high voltage source, pulling the other terminal down to that voltage
  - Normally, source terminal is connected to _____ supply voltage (+5V, +3V, etc.)



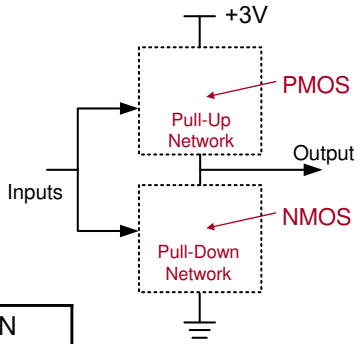
NMOS



PMOS

CMOS

- Complimentary MOS (CMOS)
  - Use PMOS to connect output to high voltage source
    - We call this the Pull-Up Network
  - Use NMOS to connect output to low voltage source (usually = GND)
    - We call this the Pull-Down Network
  - Either PMOS or NMOS should create a conductive path to output, but not both



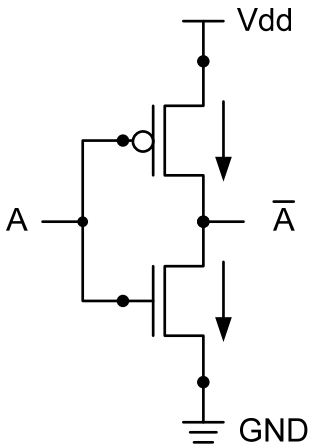
	Pull-up OFF	Pull-up ON
Pull-down OFF		
Pull-down ON		

Signal Strength

- *Strength* of signal
  - How close it approximates ideal voltage source
- V_{DD} and GND rails are strongest 1 and 0
- nMOS passes _____
  - But degraded or _____
- pMOS passes _____
  - But degraded or _____
- Thus nMOSes are best for the pull-down network, pMOSes are best for the pull-up network

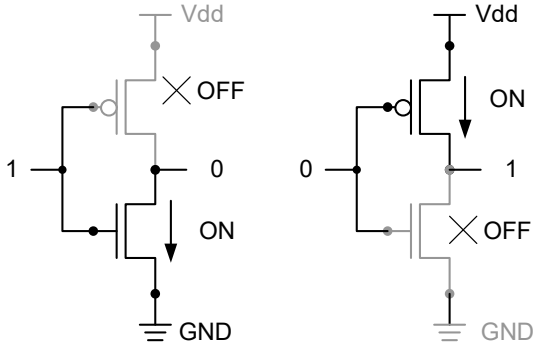
CMOS Inverter

- Inverter can be formed using one PMOS and NMOS transistor
- The input value connects to both gate inputs
- The output is formed at the junction of the drains



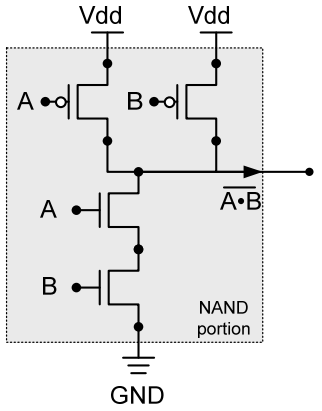
CMOS Inverter

- When input is 1, NMOS conducts and output is pulled down to 0V (GND)
- When input is 0, PMOS conducts and output is pulled up to 3V (V_{DD})



CMOS 'NAND' Gate

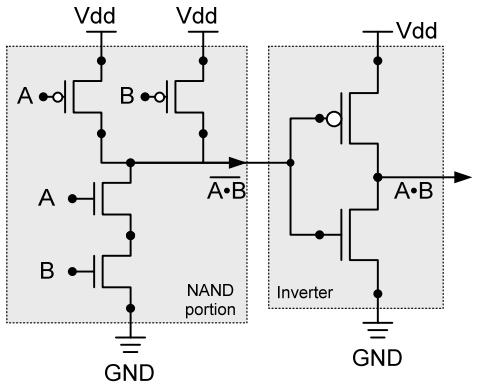
- If A and B = 1, the output of the first circuit is pulled to 0 (opposite of AND function)
- If A or B = 0, the output of the first circuit is pulled to 1 (opposite of AND function)
- Rule of *Conduction Complements*
  - Pull-up network is the dual (complement) of pull-down
  - Parallel -> series, series -> parallel



NAND

CMOS 'AND' Gate

- If A and B = 1, the output of the first circuit is pulled to 0 (opposite of AND function)
- If A or B = 0, the output of the first circuit is pulled to 1 (opposite of AND function)
- Inverter is then used to produce true AND output

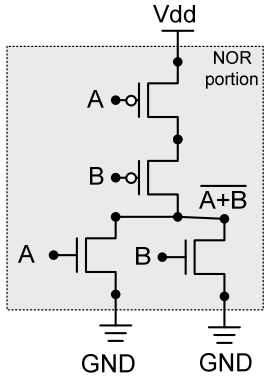


NAND

Inverter to produce AND

CMOS 'NOR' Gate

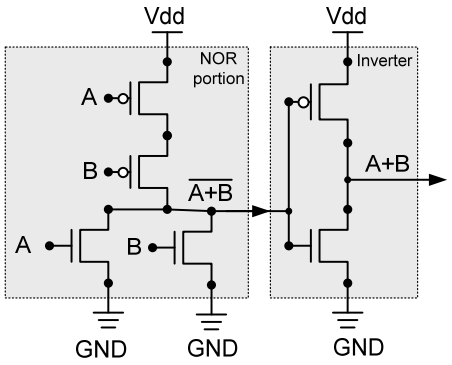
- If A or B = 1, the output of the first circuit is pulled to 0 (opposite of OR function)
- If A and B = 0, the output of the circuit is pulled to 1 (opposite of OR function)
- Rule of *Conduction Complements*
  - Pull-up network is the dual (complement) of pull-down
  - Parallel -> series, series -> parallel



NOR

CMOS 'NOR' Gate

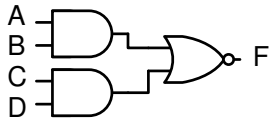
- If A or B = 1, the output of the first circuit is pulled to 0 (opposite of OR function)
- If A and B = 0, the output of the circuit is pulled to 1 (opposite of OR function)
- Inverter is then used to produce true OR output

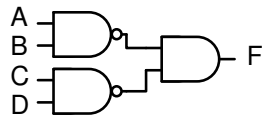


OR

Compound Gates

- How could you build this gate?
- You could try building each gate separately
  - Two AND gates = ____ transistors
  - One NOR gate = ____ transistors
- With DeMorgan's
  - Two NAND gates = ____ transistors
  - One AND gate = ___ transistors
- Or you could take build it as a single compound gate.

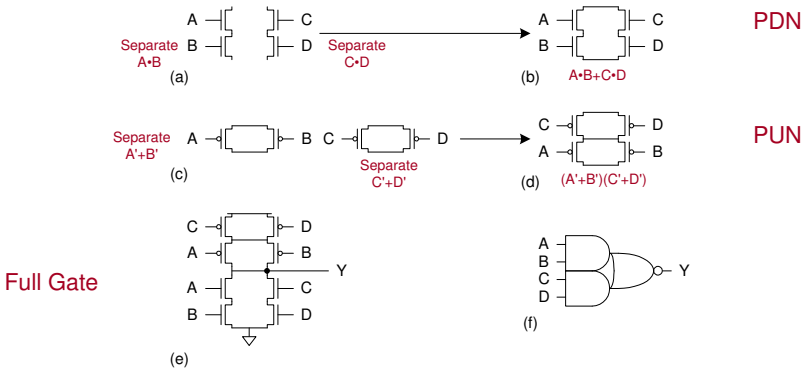




Compound Gates

- *Compound gates* can do any inverting function
- Ex: AND-OR-INVERT (AOI)

$$Y = \overline{A \cdot B + C \cdot D}$$



Compound Gate Approach

- For an inverting function just look at the expression (w/o the inversion) and…
  - Implement the PDN using:
    - Series connections for _____
    - Parallel connections for ____
  - Implement PUN as dual of PDN
    - Swap _____ and _____
- If function is non-inverting just add an inverter at the _____

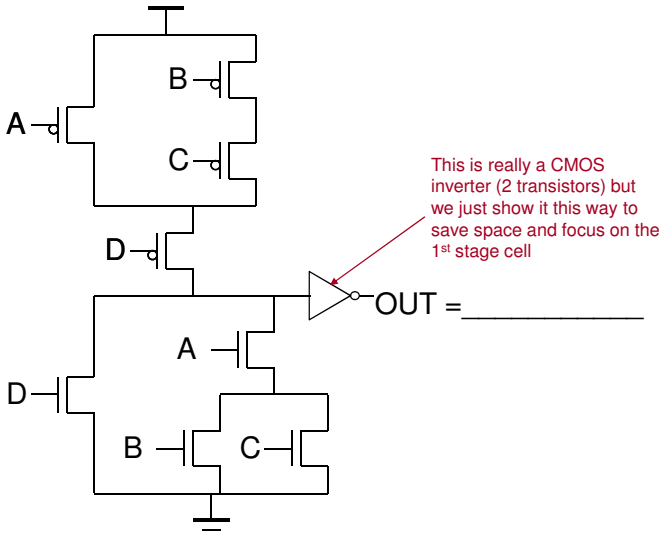
Compound Gate Example

$$Y = \overline{D \cdot (A + B + C)}$$

Compound Gate Example

$$OUT = \overline{D + A \cdot (B + C)}$$

Compound Gate Example (cont.)



This is really a CMOS inverter (2 transistors) but we just show it this way to save space and focus on the 1st stage cell

Another Compound Gate Example

$$OUT = A \cdot D + B(C + E)$$

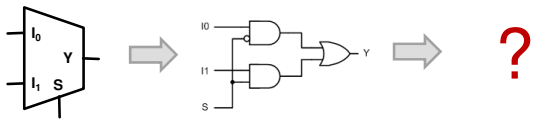
$$OUT = \overline{A \cdot D + B(C + E)}$$

Add an inverter at the output

Implement inverting function using compound CMOS gate

OR apply DeMorgan's theorem with the inner inversion and just build the resulting circuit

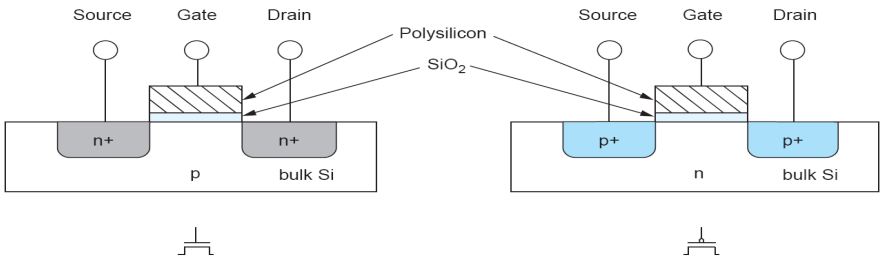
Build a 2-to-1 mux at the Transistor Level

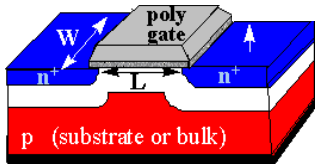


?

FABRICATION

MOS Layout Structure



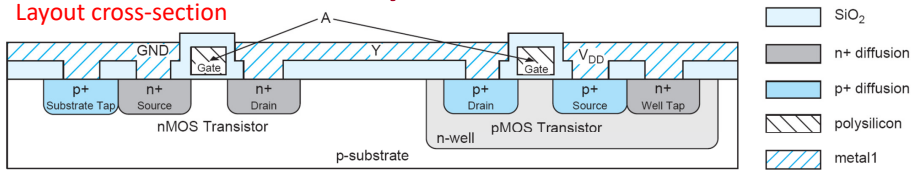


L: Channel Length

W: Channel Width

CMOS Layout Structure

Layout cross-section

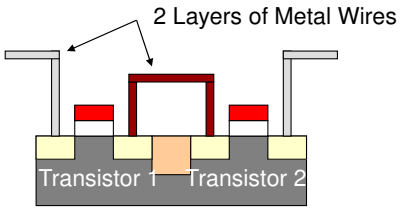


Schematic

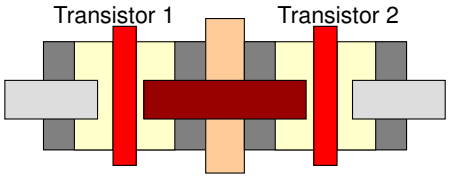
- Both n-channel (NMOS) and p-channel (PMOS) transistors are built on the same chip substrate
  - Well: A special region created in which the semiconductor type is opposite the substrate's type
    - Example: n-well
      - CMOS fabrication technology to create a n-type substrate inside the already p-type substrate
      - The n-well is used to create the PMOS transistors

Layers

- Start from the bottom up
  - Build the n- and p-type material areas on the silicon
  - Lay the insulator layer (oxide) over the silicon
  - Place the polysilicon (gate) on top of the oxide
  - Connect wires to the source, gate, and drain use layers of metal above the gate



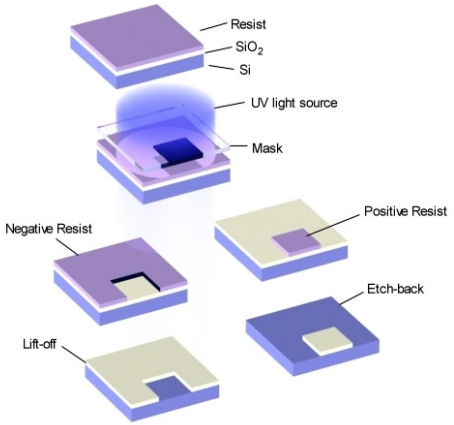
Side View



Top View

Photolithography

- An IC consists of several layers of material that are manufactured in successive steps
- Lithography is used to selectively process the layers where the 2-D mask geometry is copied on the surface
- Once the desired shape is patterned with photoresist the unprotected areas are etched away
- Lift-off and etching are different techniques to remove and shape

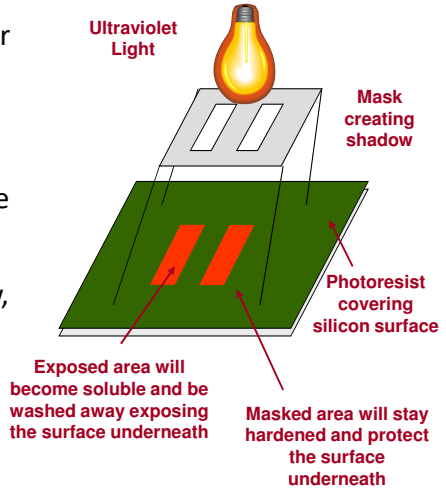


Photolithography

- Expose only specific areas of the chip for layer deposition or etching
- A layer of "photoresist" material is deposited on the chip
- "Photoresist" becomes soluble when exposed to ultraviolet light

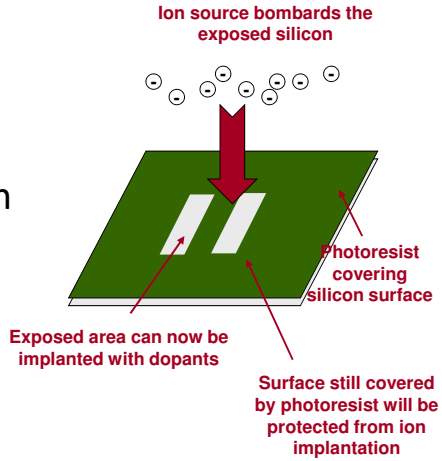
Photolithography

- Expose only specific areas of the chip for layer deposition or etching
- A layer of "photoresist" material is deposited on the chip
- "Photoresist" becomes soluble when exposed to ultraviolet light
- Using a mask to cast a shadow, some portions of photoresist can be kept while the remainder is washed away



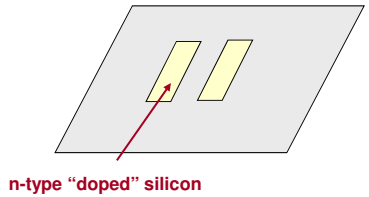
Ion Implantation

- After washing away soluble photoresist, silicon in the shape of the mask is exposed
- Can be implanted with ions to make n- or p-type material



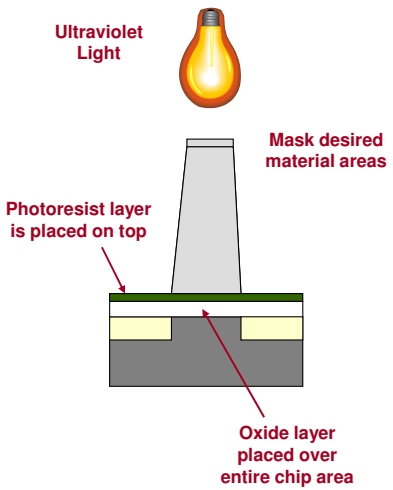
Resulting Material

- After implantation, remaining photoresist can be exposed and washed away leaving n-type silicon in the appropriate areas



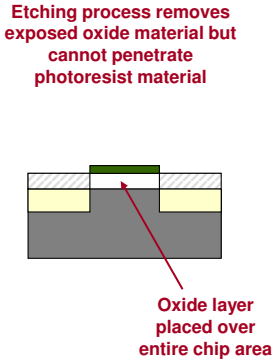
Layer Deposition

- For layers above the surface (oxide, gate polysilicon, and metal wires), a similar but slightly different process is used
  1. Entire layer of material is deposited over entire area
  2. Covered with photoresist
  3. Mask is used to indicate where material is desired



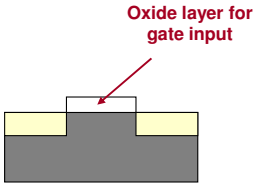
Layer Deposition

- For layers above the surface (oxide, gate polysilicon, and metal wires), a similar but slightly different process is used
  1. Entire layer of material is deposited over entire chip
  2. Covered with photoresist
  3. Mask is used to indicate where material is desired
  4. Wash away exposed photoresist
  5. Use chemical/mechanical etching process to remove exposed oxide



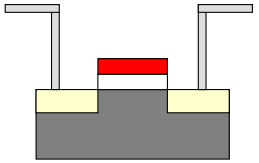
Layer Deposition

- For layers above the surface (oxide, gate polysilicon, and metal wires), a similar but slightly different process is used
  1. Entire layer of material is deposited over entire chip
  2. Covered with photoresist
  3. Mask is used to indicate where material is desired
  4. Wash away exposed photoresist
  5. Use chemical/mechanical etching process to remove exposed oxide
  6. Remaining photoresist can be removed exposing oxide in the desired location

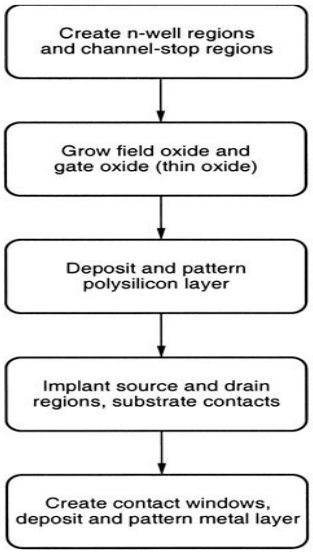


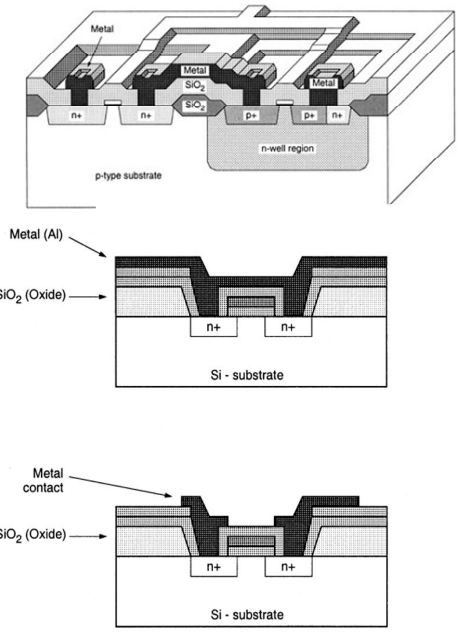
Layer Deposition

- Process is repeated for gate (polysilicon) and metal wire layers
- A separate mask is required for each layer to indicate where the substance should be kept and where it should be etched away

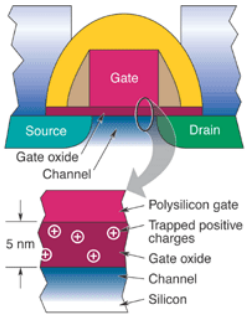


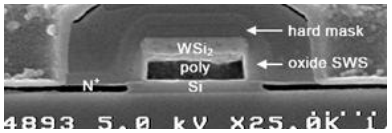
Simplified CMOS Fabrication Process

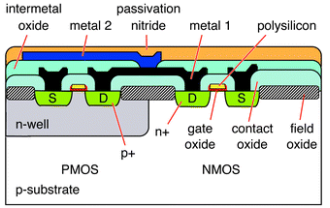


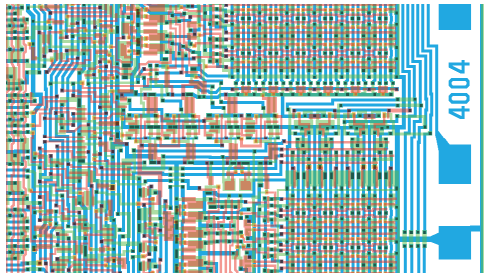


Fabrication Images









http://pubs.rsc.org/services/images/RSCpubs.ePlatform.Service.FreeContent.ImageService.svc/ImageService/Articleimage/2003/AN/b208563c/b208563c-f1.gif

http://www.4004.com/assets/4004-east-mask-detail-hdcrop.gif